



Application Serial No. 09/677,478
Supplemental IDS

MI22-1544

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No.09/677,478
Filing DateOctober 2, 2000
InventorGuy T. Blalock et al.
AssigneeMicron Technology, Inc.
Group Art Unit1765
ExaminerLan Vinh
Attorney's Docket No.MI22-1544
Title: Plasma Etching Methods

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

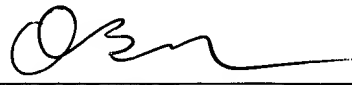
Reference - - See attached Form PTO-1449

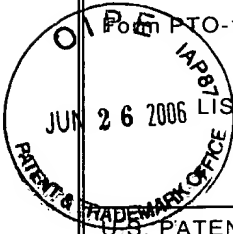
The attached Form PTO-1449 is submitted in compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the references listed on the attached Form PTO-1449. Pursuant to Federal Register Vol. 69, No. 182, pg. 56542 (September 21, 2004), no copies of any cited U.S. patents or U.S. published applications are included herewith. Copies of all other cited art references, if any, are attached. No admission is made regarding whether the submitted references are prior art.

Citation of this reference is respectfully requested.

Respectfully submitted,

Dated: 6-26-06

By: 
D. Brent Kenady
Reg. No. 40,045

		Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-1544		SERIAL NO. 09/677,478			
		LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)						APPLICANT Guy T. Blalock et al.			
								FILING DATE October 2, 2000		GROUP 1765	
U.S. PATENT DOCUMENTS											
Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate				
	AA	6,800,561	10/04	Allen III	438	714					
	AB	6,878,300 B2	04/05	Allen III	216	058					
	AC										
	AD										
	AE										
	AF										
	AG										
	AH										
	AI										
	AJ										
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FOREIGN PATENT DOCUMENTS											
		Document Number	Date	Country	Class	Subclass	Translation Yes No				
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